

Towards real-time analysis of morphologies using x-ray scattering

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Context





Outline

- High throughput data treatment
- CD-GISAXS
- Perspectives





Xi-CAM: High throughput data treatment

Develop and share data analysis algorithms







Xi-CAM: High throughput data treatment

- ✓ Xi-CAM as a platform (backend features) ✓ Each technique is a plugin! ✓ Expose your technique cross-facility
- ✓ Support multi-modal analysis





CD-SAXS plugin: Collaboration with NIST : C. LIMAN, D. SUNDAY, J. KLINE and D. DELONGCHAMPS



Xi-CAM: High throughput data treatment







CD-SAXS limitations

Transmission geometry :

=> Cross the 700 μm silicon wafer:

✓ Conventional lab-source (Cu K α , E = 8.047 keV) : T = 0.01 %

✓ High energy lab-source (Liquid Metal Jet, E > 20 keV) : T = 55 %

=> Acquisition time : > 30 minutes

Reflection geometry : GISAXS





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CD-GISAXS



Semi-circle of spots:

Intersection between the Ewald sphere and the Bragg rods coming from the grating

Probing the form factor only at few q values







CD-GISAXS







Combination of CD-GISAXS and CD-SAXS



Combination of profiles extracted by both techniques will increase the accuracy and confidence on the model





CD-GISAXS: High throughput measurement

Automation of he measurement on 7.3.3 beamline at the ALS

- Robotic arm to change the samples
- 30 seconds measurements
- Several orders => fit more precise

Fit the data on the fly (during the positioning of the new sample)



CD-GISAXS at the lab

- "Low energy source" => conventional Cu-Kα
- Simulations running on a classic computer
- A precise rotational stage is needed





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Perspectives

- ✓ Study of line roughnessCD-SAXS on periodic roughness
- ✓ Combination of CD-SAXS/GISAXS for LER/LWR roughness





 2D gratings of cylinders
(Collaboration with NIST and CEA Grenoble)











✓ Machine learning (Convolutional Neural Network)
Classification of the data and automatic pre-treatment



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Thank you for your attention!



